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DATE MAILED: 07/28/2004

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	APPLICATION NO.	FILING	DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
	08/799,506	02/12	2/1997	SHUNPEI YAMAZAKI	0756-1630	3866	
	31780 7	590	07/28/2004		EXAM	NER	
	ERIC ROBINSON PMB 955				WILCZEWSKI, MARY A		
	21010 SOUTH	BANK ST.			ART UNIT	PAPER NUMBER	
	POTOMAC FALLS, VA 20165				2822		

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)				
	Office Action Cummons	08/799,506	YAMAZAKI ET AL.				
	Office Action Summary	Examiner	Art Unit				
		Mary Wilczewski	2822				
	The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply						
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely. - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication. - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).							
Status							
1)⊠	Responsive to communication(s) filed on 20 February 2004.						
2a)□	This action is FINAL . 2b)⊠ This	action is non-final.					
3)[Since this application is in condition for allowance except for formal matters, prosecution as to the merits is						
	closed in accordance with the practice under E	Ex parte Quayle, 1935 C.D. 11, 45	3 O.G. 213.				
Dispositi	on of Claims						
4)	Claim(s) 154-186 is/are pending in the applica	tion.					
-	4a) Of the above claim(s) is/are withdrawn from consideration.						
5)⊠	5)⊠ Claim(s) <u>169-186</u> is/are allowed.						
6)⊠	Claim(s) <u>154,156,159,161,164 and 166</u> is/are	rejected.					
7)⊠	7) Claim(s) <u>155,157,158,160,162,163,165,167 and 168</u> is/are objected to.						
8)□	Claim(s) are subject to restriction and/o	r election requirement.					
Applicati	on Papers						
9) The specification is objected to by the Examiner.							
10)☐ The drawing(s) filed on is/are: a)☐ accepted or b)☐ objected to by the Examiner.							
	Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).						
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).							
11)	The oath or declaration is objected to by the Ex	caminer. Note the attached Office	Action or form PTO-152.				
Priority u	ınder 35 U.S.C. § 119						
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No. 08/330,797. 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 							
Attachment(s)							
1) Notice of References Cited (PTO-892) 4) Interview Summary (PTO-413) 2) Paper No(s)/Mail Date							
3) 🔯 Inform	e of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449 or PTO/SB/08) r No(s)/Mail Date 5/11/04; 5/24/04.		atent Application (PTO-152)				

Application/Control Number: 08/799,506

Art Unit: 2822

DETAILED ACTION

This Office action is in response to the Terminal Disclaimer filed on February 20, 2004, and the Information Disclosure Statements filed on May 11, 2004, and May 24, 2004.

Priority

Acknowledgment is made of applicant's claim for foreign priority under 35 U.S.C. 119(a)-(d). The certified copy has been filed in parent Application No. 08/330,797, filed on October 28, 1994.

Drawings

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claims 154, 156, 159, 161, 164, and 166 are rejected under 35

U.S.C. 102(e) as being clearly anticipated by Yagi et al., U.S. Patent 5,344,522, newly cited by Applicants.

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Yagi et al. disclose a method of manufacturing a thin film semiconductor device which uses a multi-chambered apparatus (Figure 6) in which an amorphous silicon film is formed over a substrate and irradiated with an excimer laser in a first chamber in an atmosphere comprising oxygen, the substrate is transported to a second chamber and a silicon nitride gate insulating film is formed in the second chamber without exposing the gate insulating film to air, the first and second chambers connected with each other through a preliminary chamber. (See Example 9, specifically, col. 25, lines 48-50; col. 27, lines 10-11, lines 29-35; and col. 28, lines 59-61.)

Allowable Subject Matter

Claims 169-186 are allowable over the prior art of record.

Claims 155, 157, 158, 160, 162, 163, 165, 167, and 168 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to M. Wilczewski whose telephone number is (571) 272-1849. The examiner can normally be reached on Monday and Thursday.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

M. Wilczewski Primary Examiner Tech Center 2800